



Attorney Docket No. 015290-506 Patent AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Ting CHIEN et al.

Application No.: 09/820,692

Filing Date: March 30, 2001

Title: PLASMA ETCHING OF DIELECTRIC LAYER WITH SELECTIVITY TO STOP LAYER

MAIL STOP: AF

Group Art Unit: 1765

Examiner: K. C. Chen

Confirmation No.: 5245

NOTICE OF APPEAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

All finally rejected claims in the decision of the Primary Examiner dated October 7, 2003 are hereby appealed to the Board of Patent Appeals and Interferences.

- ☐ The appeal fee was previously paid on _____. Therefore, no Appeal fee is now required.
- ☐ Enclosed is the Appeal fee of: ☐ \$165.00 (2401) ☐ \$330.00 (1401)
- ☒ Please charge the Appeal fee of ☐ \$165.00 (2401) ☒ \$330.00 (1401) to Deposit Account No. 02-4800.
- ☒ A Petition for Extension of Time is enclosed.
- ☐ Small entity status is hereby claimed.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

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Date: March 8, 2004

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